

FORM PTO-1449 MODIFIED INFORMATION DISCLOSURE CITATION IN AN APPLICATION			Docket No.: I431.101.101 (2002P15009US)	Application No.: Unknown		
			APPLICANT: Andreas Meckes et al.			
			FILING DATE: Herewith			
			GROUP ART UNIT: Unknown			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>ZKS</i>	4,744,863	05-1988	Guckel et al.			
	5,090,254	02-1992	Guckel et al.			
	5,454,906	10-1995	Baker et al.			
	5,872,493	02-1999	Ella			
	6,114,635	09-2000	Lakin et al.			
	6,232,150	05-2001	Lin et al.			
	2001/0001293	05-2001	Gotoh et al.			
	2001/0004085	06-2001	Gueissaz			
	6,550,664	04-2003	Bradley et al.			
FOREIGN PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>ZKS</i>	101 05 351 A 1	08-2002	DE			<input checked="" type="checkbox"/> X
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)						
<i>ZKS</i>	Mei et al., "Process Characterization and Analysis of Sealed Vacuum Microelectric Devices," J. Vac. Sci. Techn. B 12(2), March/April 1994, pp. 638-643.					
<i>ZKS</i>	Hakan Ederstig, Per Wallgren, "Spin Desposition of Polymers over Holes and Cavities," Sensors and Actuators A46-47, 1995, pp. 95-97.					
EXAMINER SIGNATURE 		DATE CONSIDERED <i>10/3/05</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						